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JC09 Rec'd T/PTO 24 JUN 2005

PATENT  
450101-04870.1

XV

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Koichiro KISHIMA et al.

International Application No.: PCT/JP2004/016188

International Filing Date: October 25, 2004

For: METHOD FOR MANUFACTURING  
SEMICONDUCTOR SUBSTRATE AND  
SEMICONDUCTOR SUBSTRATE

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New York, NY 10151

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Sir:

Enclosed are copies of the publications, which were cited in the International Search Report of International Application No. PCT/JP2004/016188. Also enclosed is a copy of Form PTO-1449 and the International Search Report.

In the event the above-identified patent application was filed after June 30, 2003 or is an international application that entered the national stage under 35 U.S.C. 371 after June

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**REMARKS**

Entry of this Information Disclosure Statement and an early examination on the merits are respectfully solicited.

Please charge any additional fees to Deposit Account No. 50-0320.

Respectfully submitted,

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Enclosures

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Sheet 1 of 1

Based on Form PTO-1449 (3/90)		ATTY. DOCKET NO. 450101-04870.1	SERIAL NO. Filed Concurrently Herewith
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Koichiro KISHIMA et al.	
		FILING DATE Filed Concurrently Herewith	GROUP

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	2002/0022348	02/21/02	SAKAGUCHI et al.			
	AB	2003/0104681	06/05/03	Duvari et al.			
	AC	5, 930, 642	07/27/99	Moore et al.			
	AD	6, 593, 173	07/15/03	Anc et al.			
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	AH	EP 0 966 034	12/22/99	Europe			
	AI	JP 2000-77352	03/14/00	Japan			
	AJ	GB 2 183 905	06/10/87	U.K.			
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AQ		PATENT ABSTRACTS OF JAPAN, Publication No. 2000357665, Publication Date December 26, 2000				
	AR		PATENT ABSTRACTS OF JAPAN, Publication No. 2003124305, Publication Date April 25, 2003				
	AS						

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